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Docket No.: M4065.0353/P353-A
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Gurtej Sandhu et al.

Application No.: 09/982,954 Confirmation No.: 8784

Filed: October 22, 2001 Art Unit: 1763

For: ATOMIC LAYER DOPING APPARATUS
AND METHOD Examiner: K. A. Moore

RESPONSE AFTER FINAL ACTION UNDER 37 C.F.R. § 1.116

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated February 7, 2007, finally rejecting claims 1, 7-10 and 46-52, please reconsider the above-identified U.S. patent application in light of the following:

Listing of the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.